

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

## Title of Invention

METHOD FOR MANUFACTURING TUNGSTEN/POLYSILICON  
WORD LINE STRUCTURE IN VERTICAL DRAM AND DEVICE  
MANUFACTURED THEREBY

Application Number :

Confirmation Number:

First Named Applicant: Ramachandra Divakaruni

Attorney Docket Number: FIS920030421US1

Art Unit:

Examiner:

Search string: ( 6346734 or 6475893 or 6541810 or 6326260 or 6620677 or 6610573 or 6620676  
or 20020196651 ).pn

## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

| init | Cite.No. | Patent No. | Date       | Patentee           | Kind | Class | Subclass |
|------|----------|------------|------------|--------------------|------|-------|----------|
|      | 1        | 6346734    | 2002-02-12 | Divakaruni, et al. |      |       |          |
|      | 2        | 6475893    | 2002-11-05 | Giewont, et al.    |      |       |          |
|      | 3        | 6541810    | 2003-04-01 | Divakaruni, et al. |      |       |          |
|      | 4        | 6326260    | 2001-12-04 | Divakaruni, et al. |      |       |          |
|      | 5        | 6620677    | 2003-09-16 | Hummler            |      |       |          |
|      | 6        | 6610573    | 2003-08-26 | Weis               |      |       |          |
|      | 7        | 6620676    | 2003-09-16 | Malik, et al.      |      |       |          |

## US Published Applications

**Note: Applicant is not required to submit a paper copy of cited US Published Applications**

| init | Cite.No. | Pub. No.    | Date       | Applicant | Kind | Class | Subclass |
|------|----------|-------------|------------|-----------|------|-------|----------|
|      | 1        | 20020196651 | 2002-12-26 | Weis      |      |       |          |

## Signature

|               |      |
|---------------|------|
| Examiner Name | Date |
|               |      |